

MS RCE
PATENT
8074-1143

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Koichi NANIWAE Conf. 9283

Application No. 10/573,492 Group 2892

Filed May 15, 2006 Examiner E. Jones

METHOD OF CLEANING TREATMENT AND METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

AMENDMENT TO ACCOMPANY A REQUEST FOR CONTINUED EXAMINATION

Assistant Commissioner for Patents July 1, 2009
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in
response to the final Office Action dated April 1, 2009,
together with a Request for Continued Examination (RCE)
together filed concurrently herewith.

Amendments to the Claims are reflected in the listing of
claims, which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.